Technical Specifications		
Ellipsometer	Auto-Nulling Imaging Ellipsometer in PSCA configuration	
Ellipsometric precision	Delta/Psi precision 0.002 deg	
and accuracy	Absolute accuracy 0.1 deg	
Thickness relative error (SiO2 on Si)	0.001 nm	
Thickness absolute		
accuracy	< 0.1 nm	
(SiO2 on Si)		
Imaging system	CCD camera with 768 x 572 pixels	
	Laser unit:	
	Internal solid state laser, 532 nm	
Light source	Spectroscopic Unit:	
	Xenon Arc lamp with filter wheel (48 interference filters).	
	Wavelengths: 380 – 900 nm, bandwidth +/- 6 nm	
Imaging optics	To achieve high-resolution real-time focused images, the Nanofilm EP ³ is equipped with an	
	10x objective:	
	Field of view 0.4 mm. lateral resolution: 2 um	
	Sy objective:	
	Field-of-view 0.89 mm, lateral resolution: 3 µm	
	2x objective:	
	Field-of-view 2.5 mm, lateral resolution: 4 µm	
Motorized goniometer	Angle-of-incidence range: 40 – 90 deg.	
	Angle resolution: 0.001 deg.	
	Absolute angle accuracy: 0.01 deg.	
	Speed of motion: ca. 10 deg./second	
Automatic sample	Automatic Sample Alignment: typ. 2 sec/ deg	
handling stage	Motorized XYZ stage: travel range 90 mm (X/Y), 3 mm (Z)	
	Repeatability: 1 µm	

	Joystick: MS WingMan
Reflective liquid cell - <u>image</u>	For ellipsometry of solid substrates in liquid.
	Angle of incidence: 60°
	Material: PEEK
	Liquid Volume: < 0.4 ml
	Windows: AR-coated glass
	Sample size: minimum15 x 22 mm
SPR/TIR liquid cell - <u>image</u>	Liquid cell for ellipsometry of transparent substrates and/or SPR measurements.
	Material: PEEK
	Liquid volume: < 100 μl
	Sample size: minimum15 x 22 mm
EP ³ View Software:	Automation:
	* Powerful macro language EP ³ script allows the user to simplify complex measurements into
	push-button operation
	* User-programmable function buttons
	* X/Y stages controlled via software
	Image Processing:
	* AutoScan for optimum full field-of-view images
	* Real-time geometrical correction for angle-dependent image aspect ratio
	* Image formats supported: TIFF, JPG, PNG
	* Image browser
	Analysis:
	* Multiple region-of-interest (ROI)
	* Micro Mapping for high-res maps of Delta/Psi, thickness, refractive index etc.
	* Optical modelling package for simulation and analysis of thin film systems, supports
	multiple-angle, multiple-wavelength and spectroscopic analysis
	* Export data to external software packages for analysis or visualization
	* Kinetic software add-on for evaluation of binding events